1.	NIHI	E UNITED STATES	PATENT AN	ND TRADEMARK OFFICE
Applicant	:	Raaijmakers et al.) Group Art Unit Unknown
App. No.	:	Unknown)
Filed	:	January 18, 2001)
For	:	METHOD OF DEP SILICON WITH H COVERAGE	OSITING IGH STEP)))
Examiner	:	Unknown)))
		INFORMATION	DISCLOSUR	E STATEMENT
Washington, D		oner for Patents 0231		
Dear Sir:				
Enclose	ed is fo	orm PTO-1449 listing	references, wl	hich are not being provided pursuant to
37 CFR §1.98(d), as 1	they were previously e	either cited by	the Office or disclosed in parent
application Ser	ial No	. 09/264,167, filed Ma	arch 5, 1999.	This Information Disclosure Statement
is being filed w	ithin t	hree months of the file	ng date of this	s application, and no fee is required in
accordance wit	h 37 C	.F.R. § 1.97(b)(1).	ing date of this	s application, and no fee is required in
			Respectfully	submitted,
			KNOBBE, N	MARTENS, OLSON & BEAR, LLP
Dated: January	18, 200	01	Ву:	deel Sugal Oblita
			Adeel S. Registrati	Akhtar ion No. 41,349
				of Record
		•	•	nort Center Drive

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